

In the Specification

On Page 30, before the first full paragraph, please insert the following:

Furthermore, the process or the optical system according to the invention can be used in combination with conventional optical microscopy processes, particularly in combination with standard far field microscopy, epifluorescence microscopy, confocal microscopy, 4Pi microscopy, theta microscopy, near field microscopy, microscopic I²M, I³M and I⁵M processes, STED processes and multiphoton microscopy.